

**PATENT APPLICATION**

**RESPONSE UNDER 37 CFR §1.116  
EXPEDITED PROCEDURE  
TECHNOLOGY CENTER ART UNIT 2882**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroaki TAKAIWA et al.

Group Art Unit: 2882

Application No.: 10/587,268

Examiner: M. LIU

Filed: July 26, 2006

Docket No.: 128865

For: IMMERSION EXPOSURE APPARATUS AND DEVICE MANUFACTURING  
METHOD WITH LIQUID DETECTION APPARATUS

**AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the March 5, 2010 Office Action, the shortened statutory period for reply  
being extended by the attached Petition for Extension of Time, please consider the following:

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**